



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL Application of)
Shunpei YAMAZAKI et al.)
Based On Serial No. 09/190,828) Art Unit: 2811
Which Was Filed: November 12, 1998) Examiner: S. Loke
For: INSULATING FILM FORMED)
USING AN ORGANIC SILANE)
AND METHOD OF PRODUCING)
SEMICONDUCTOR DEVICE) Date: December 20, 1999

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

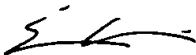
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/190,828 filed November 12, 1998, and the predecessor

applications including Serial Nos. 08/734,127; 08/445,574; 08/198,054, and 07/781,930.

Respectfully submitted,



Eric J. Robinson
Registration No. 38,285

Sixbey, Friedman, Leedom & Ferguson, P.C.
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110